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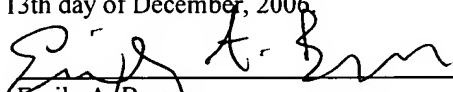
THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yeshwanth Narendar et al.  
Serial No: 10/752,434  
Confirmation No: 3742  
Filed: January 6, 2004  
For: HIGH PURITY SILICON CARBIDE ARTICLES AND METHODS

Examiner: Karl E. Group  
Art Unit: 1755

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Emily A. Berger

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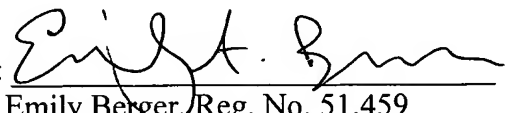
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- ☒ Information Disclosure Statement Filed Pursuant to the Duty of Disclosure Under 37 CFR §§1.56, 1.97 and 1.98 and PTO Form 1449
- ☒ Amendment
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If the enclosed papers are considered incomplete, the Mail Room and/or the Application Branch is respectfully requested to contact the undersigned at (617) 395-7000.

A check for \$180.00 is enclosed. If the fee required differs from the amount enclosed, the Commissioner is hereby authorized to charge any underpayment to or refund any overpayment to Deposit Account No. 50/2762.

Respectfully submitted,  
*Yeshwanth Narendar, et al., Applicants*

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Date: December 13, 2006